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## \*BIBDATASHEET\*

**CONFIRMATION NO. 9693** 

Bib Data Sheet											
SERIAL NUME 10/620,970		FILING DATE 07/17/2003 RULE	C	CLASS 117	GROUP ART UNIT 1765		ATTORNEY DOCKET NO. T36-157933M/KOH				
Akira Kojir Kazuyoshi ** CONTINUING ** FOREIGN API	ma, Ni i Tomi DATA PLICA	0VU	<b>V</b> ;								
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/20/2003											
Foreign Priority claimed  35 USC 119 (a-d) conditions  The purple of the			<u> </u>	STATE OR COUNTRY JAPAN			TOTA CLAII 11	MS	INDEPENDENT CLAIMS 1		
ADDRESS 21254 MCGINN & GIBE 8321 OLD COUF SUITE 200 VIENNA , VA 22182-3817											
TITLE Method for produ	ıcing s	semiconductor crystal									
FILING FEE	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT FEE No for following:						All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)				



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APPLICANTS		,									
Seiji Naga	i, Nish	nikasugai-gun, JAPAN;									
		shikasugai-gun, JAPAN ta, Nagoya-shi, JAPAN									
** CONTINUING	DATA	hone	•								
** FOREIGN APPLICATIONS ************************************											
IF REQUIRED, F ** 10/20/2003	OREI	GN FILING LICENSE (	GRANTE	ĒD							
Foreign Priority claimed yes one of the state of the stat					SHE	SHEETS TO		AL	INDEPENDENT		
35 USC 119 (a-d) conditions yes no Met after met  Verified and Examiner's Signature Initials			COUNTRY JAPAN	DRAWING 1		CLAII 11		CLAIMS 1			
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